IN THE CLAIMS:

1. (Currently Amended) A method of manufacturing an electronic-charge-transferring device comprising:

providing a charged species source and a ~~charge~~ charged species drain; and

positioning ~~providing~~ a movable component, having a size of a micrometer scale or smaller and being operable to transfer ~~for transferring~~ charge to the charged species drain, in close proximity to the charged species source;

positioning a first protrusion having a size of a micrometer scale or smaller proximate to the moveable component~~,~~; and

positioning a second protrusion having a size of a micrometer scale or smaller proximate to the moveable component~~, wherein the moveable component is positioned in close proximity to the charged species source, and wherein at least one of the moveable component, the first protrusion and the second protrusion is of a micrometer scale or smaller~~.

2. (Currently Amended) The method of claim 1, wherein the providing a charged species source and a charge species drain step comprises providing a charged species source having a size of a micrometer scale or smaller.

3. (Currently Amended) The method of claim 1, wherein the providing a charged species source and a charge species drain step comprises providing a charged species drain having a size of a micrometer scale or smaller.

4. (Currently Amended) The method of claim 1, wherein the providing a charged species source and a ~~charge~~ charged species drain step comprises providing the charged species source and the charged species drain in contact with the moveable component.

5. (Currently Amended) The method of claim 1, ~~wherein the providing a movable component step comprises~~ further comprising including a first material in the first protrusion and a second material, different from the first material, in the second protrusion.

6. (Currently Amended) The method of claim 5, ~~wherein the providing a movable component step comprises~~ further comprising including a third material, different from the first material and the second material, in the moveable component.

7. (Original) The method of claim 1, further comprising positioning the first protrusion and the second protrusion in contact with the moveable component.

8. (Original) The method of claim 1, further comprising electrically connecting a device to the charged species drain.

Claims 9-20 (Cancelled).

21. (Previously Presented) The method of claim 1, wherein at least one of the moveable component, the first protrusion and the second protrusion is of a nanometer scale.

22. (Previously Presented) The method of claim 1, wherein at least one of the charged species source and the charged species drain is of a nanometer scale.

23. (Previously Presented) The method of claim 1, wherein the movable component is a nonconductive plate.

24. (Previously Presented) The method of claim 11, wherein the movable component is operable to be one of rotated and translated.

Claims 25-32 (Cancelled).